

024-23-04

Express Mail No. EV 809 346 864 US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Laurent FILIPOZZI et al.

Confirmation No. 1944

Application No: 10/621,122

Group Art Unit: 3723

Filing Date: July 15, 2003

Examiner:

For: SURFACE PREPARATION FOR RECEIVING
PROCESSING TREATMENTS

Atty. Docket No.: 4717-8100

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Pursuant to applicants' duty of disclosure under 37 C.F.R. 1.56, applicants submit herewith one (1) reference for the Examiner's review and consideration. This reference was cited in the International Search Report and a copy is enclosed.

This reference is listed on the enclosed Form PTO-1449. It is respectfully requested that this references be made of record in this application by the Examiner's completion and return of the PTO Form 1449.

No fee or certification is believed to be due for this submission since the references are being submitted prior to an initial office action for this application. Should any fees be required, however, please charge such fees to **Winston & Strawn** LLP Deposit Account No. 50-1814.

Date: 4/21/04

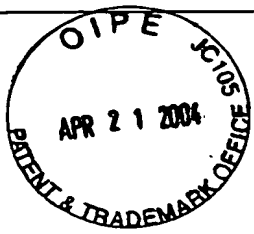
Respectfully submitted,

Allan A. Fanucci (Reg. No. 30,256)

WINSTON & STRAWN LLP
CUSTOMER NO. 28765

Enclosures

(212) 294-3311

				ATTY. DOCKET NO.:		APPLICATION NO.:	
				4717-8100		10/621, 122	
				APPLICANT:			
				Laurent FILIPOZZI et al			
				FILING DATE:		GROUP:	
				July 15, 2003		3723	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
	AF						
	AG						
	AH						
	AI						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AJ	Michael L. Free, XP-002266271, "Using Surfactants in iron-based CMP slurries to minimize residual particles", Surface Chemistries, Micromagazine (1998)					
	AK						
	AL						
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							